

Supplementary information for High quality 6-inch single-crystalline AlN template for E-mode HEMT power device

Zhiwen Liang¹, Shangfeng Liu^{1,3,7}, Ye Yuan^{1,*}, Tongxin Lu^{1,7}, Xiaopeng Li¹, Zirong Wang⁶, Neng Zhang⁶, Tai Li^{1,7}, Xiangdong Li^{2,*}, Qi Wang⁵, Shengqiang Zhou⁴, Kai Kang⁶, Jincheng Zhang^{2,8}, Yue Hao^{2,8} and Xinqiang Wang^{1,5,7,*}

¹ Songshan Lake Materials Laboratory, Dongguan, Guangdong, 523808, People's Republic of China

² Guangzhou Wide Bandgap Semiconductor Innovation Center, Guangzhou Institute of Technology, Xidian University, Guangzhou 510555, China

³ School of Physical Sciences, Great Bay University, Dongguan, 523808 China

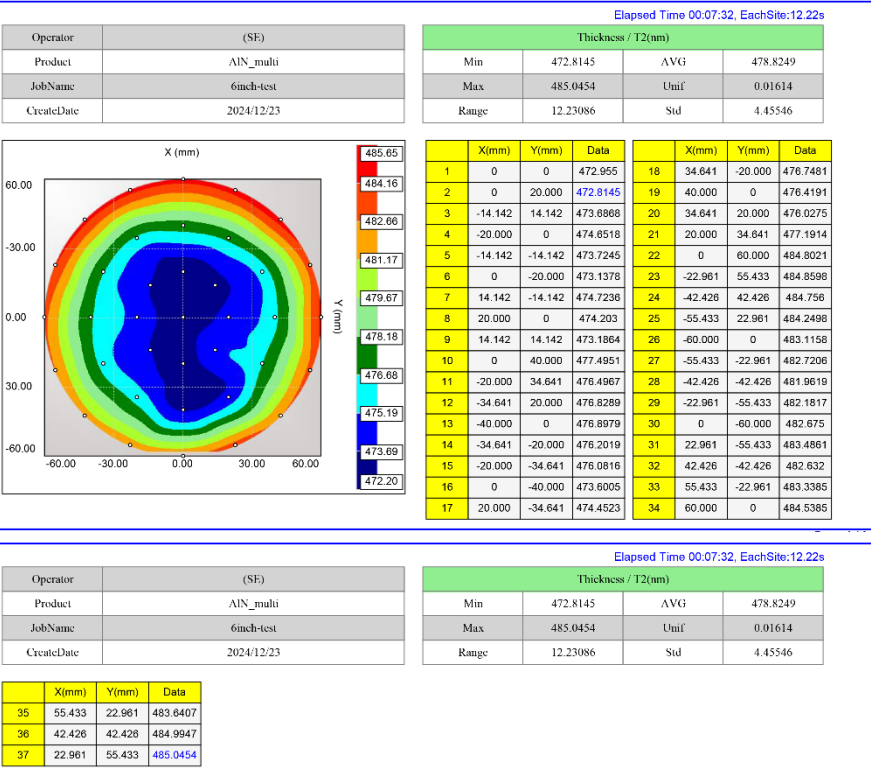
⁴ Helmholtz-Zentrum Dresden-Rossendorf, Institute of Ion Beam Physics and Materials Research, Bautzner Landstrasse 400, 01328, Dresden, Germany

⁵ Dongguan Institute of Opto-Electronics Peking University, Dongguan, 523808, China

⁶ Sinopatt. Technology Co., Ltd, Songshan Lake, Dongguan City, Guangdong Province, 523808, China

⁷ State Key Laboratory of Artificial Microstructure and Mesoscopic Physics, School of Physics, Nano-Optoelectronics Frontier Center of Ministry of Education (NFC-MOE), Peking University, Beijing 100871, China

⁸ State Key Laboratory of Wide Bandgap Semiconductor Devices and Integrated Technology, School of Microelectronics, Xidian University, Xi'an 710071, China



Thickness / T2(nm)

Min

472.8145

AVG

478.8249

Max

485.0454

Unif

0.01614

Range

12.23086

Std

4.45546

X(mm)

Y(mm)

Data

35

55.433

22.961

483.6407

36

42.426

42.426

484.9947

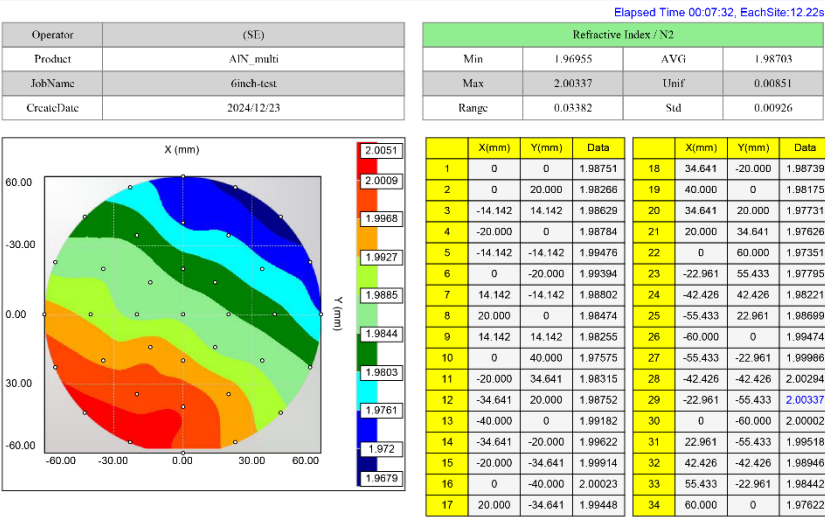
37

22.961

55.433

485.0454

Figure S1 Thickness mapping (37 points) of 6 inch single-crystalline AIN template measured by ellipsometer



Elapsed Time 00:07:32, EachSite:12.22s

Refractive Index / N2

Min

1.96955

AVG

1.98703

Max

2.00337

Unif

0.00851

Range

0.03382

Std

0.00926

X(mm)

Y(mm)

Data

35

55.433

22.961

1.97336

36

42.426

42.426

1.96955

37

22.961

55.433

1.97089

Figure S2 Refractive Index mapping (37 points) of 6 inch single-crystalline AlN template measured by ellipsometer